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APPLICATION NO.	FILING DATE	FIRST NAMED INVENTOR	ATTORNEY DOCKET NO.	CONFIRMATION NO.	
09/887,165	06/25/2001	Calvin T. Gabriel	50432-096	7774	
7	590 10/03/2002				
McDERMOTT, WILL & EMERY			EXAMINER		
600 13th Street, N. W. Washington, DC 20005-3096			GOUDREAU,	GEORGE A	
			ART UNIT	PAPER NUMBER	
	•		1763	3	
			DATE MAILED: 10/03/2002	DATE MAILED: 10/03/2002	

Please find below and/or attached an Office communication concerning this application or proceeding.



Office Asticus Occurrence	Application No. 165 (Fabriel et al				
Office Action Summary	Examiner Group Art Unit				
	beorge Goudrese 1763				
—The MAILING DATE of this communication appears on the cover sheet beneath the correspondence address—					
Period for Reply					
A SHORTENED STATUTORY PERIOD FOR REPLY IS SET TO EXPIRE MONTH(S) FROM THE MAILING DATE OF THIS COMMUNICATION.					
 Extensions of time may be available under the provisions of 37 CFR 1.136(a). In no event, however, may a reply be timely filed after SIX (6) MONTHS from the mailing date of this communication. If the period for reply specified above is less than thirty (30) days, a reply within the statutory minimum of thirty (30) days will be considered timely. If NO period for reply is specified above, such period shall, by default, expire SIX (6) MONTHS from the mailing date of this communication. Failure to reply within the set or extended period for reply will, by statute, cause the application to become ABANDONED (35 U.S.C. § 133). Any reply received by the Office later than three months after the mailing date of this communication, even if timely, may reduce any earned patent term adjustment. See 37 CFR 1.704(b). 					
Status					
Responsive to communication(s) filed on 6-01 (Ce - papers # 1-2)					
☐ This action is FINAL .					
□ Since this application is in condition for allowance except for formal matters, prosecution as to the merits is closed in accordance with the practice under Ex parte Quayle, 1935 C.D. 1 1; 453 O.G. 213.					
Disposition of Claims					
Claim(s) - 2	Is/are pending in the application.				
10 >1	is/are withdrawn from consideration.				
Claim(s) 12-21 is/are allowed.					
ζ'	is/are rejected.				
☐ Claim(s)	·				
□ Claim(s)	are subject to restriction or election				
Application Papers ☐ The proposed drawing correction, filed on is ☐ approved ☐ disapproved.					
☐ The drawing(s) filed on is/are objected to by the Examiner					
☐ The specification is objected to by the Examiner.					
☐ The oath or declaration is objected to by the Examiner.					
Priority under 35 U.S.C. § 119 (a)–(d)					
☐ Acknowledgement is made of a claim for foreign priority under 35 U.S.C. § 119 (a)-(d).					
☐ All ☐ Some* ☐ None of the:					
☐ Certified copies of the priority documents have been received.					
 □ Certified copies of the priority documents have been received in Application No. □ Copies of the certified copies of the priority documents have been received 					
in this national stage application from the International Bureau (PCT Rule 17.2(a))					
*Certified copies not received:					
Attachment(s)	·				
Information Disclosure Statement(s), PTO-1449, Paper No(s)	Interview Summary, PTO-413				
Notice of Reference(s) Cited, PTO-892	□ Notice of Informal Patent Application, PTO-152				
☐ Notice of Draftsperson's Patent Drawing Review, PTO-948	□ Other				
Office Action Summary					

U.S. Patent and Trademark Office PTO-326 (Rev. 11/00)

Part of Paper No.

Application/Control Number: 09/887,165

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15. The following is a quotation of the appropriate paragraphs of 35 U.S.C. 102 that form the basis for the rejections under this section made in this Office action:

A person shall be entitled to a patent unless --

- (b) the invention was patented or described in a printed publication in this or a foreign country or in public use or on sale in this country, more than one year prior to the date of application for patent in the United States.
- (e) the invention was described in a patent granted on an application for patent by another filed in the United States before the invention thereof by the applicant for patent, or on an international application by another who has fulfilled the requirements of paragraphs (1), (2), and (4) of section 371© of this title before the invention thereof by the applicant for patent.
- 16. Claims 1-11 are rejected under 35 U.S.C. 102(b) as being anticipated by Arleo et. al. (5,176,790).

Arleo et. al. disclose a process for anisotropically rie etching a dielectric layer on a wafer selectively to an underlying metal layer on the wafer using a patterned photo resist etch mask, and a plasma which is comprised of a N compound, a F compound, and an inert gas. The nitrogen compound may be any combination of N2O, NH3, etc. The F compound may be any combination of NF3, CHF3, etc. The inert gas may be any of Ar, He, etc. This is discussed specifically in columns 2-4, 7; and discussed in general in columns 1-12. This is shown in figures 1-3.

- 17. Claims 12-21 are allowed.
- 18. The prior art made of record and not relied upon is considered pertinent to applicant's disclosure.
- 19. Any inquiry concerning this communication or earlier communications from the examiner should be directed to Examiner George A. Goudreau whose telephone number is (703) -308-1915. The examiner can normally be reached on Monday through Friday from 9:30 to 6:00.

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If attempts to reach the examiner by telephone are unsuccessful, the examiner's supervisor, Examiner Gregory Mills, can be reached on (703) -308-1633. The appropriate fax phone number for the organization where this application or proceeding is assigned is (703) -306-3186.

Any inquiry of a general nature or relating to the status of this application or proceeding should be directed to the receptionist whose telephone number is (703) -308-0661.

George A. Goudreau/gag

Primary Examiner

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